

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10694986
<b>Filing Date:</b>	29-Oct-2003
<b>Title of Invention:</b>	METHOD FOR REMOVING RESIST PATTERN AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE
<b>First Named Inventor/Applicant Name:</b>	Masaharu Nagai
<b>Filer:</b>	John F. Hayden/April Saunders-Fuller
<b>Attorney Docket Number:</b>	12732-0171001

Filed as Large Entity

### Utility under 35 USC 111(a) Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
Utility Appl issue fee	1501	1	1510	1510
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				1810